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APPLICANTS

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** CONTINUING DATA *****

This application is a 371 of PCT/JP03/08360 07/01/2003

** FOREIGN APPLICATIONS *****

JAPAN 2002-193733 07/02/2002

Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no	35 USC 119 (a-d) conditions <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input checked="" type="checkbox"/> Met after met	STATE OR COUNTRY JAPAN	SHEETS DRAWING 5	TOTAL CLAIMS 31	INDEPENDENT CLAIMS 5
Verified and Acknowledged <i>[Signature]</i>	Examiner's Signature <i>[Signature]</i> Initials <i>[Initials]</i>				

ADDRESS

00466

TITLE

Group III nitride semiconductor substrate and its manufacturing method

FILING FEE RECEIVED 1980	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit
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